

CEPC HCAL Progress

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On behalf of CEPC Calorimeter working group



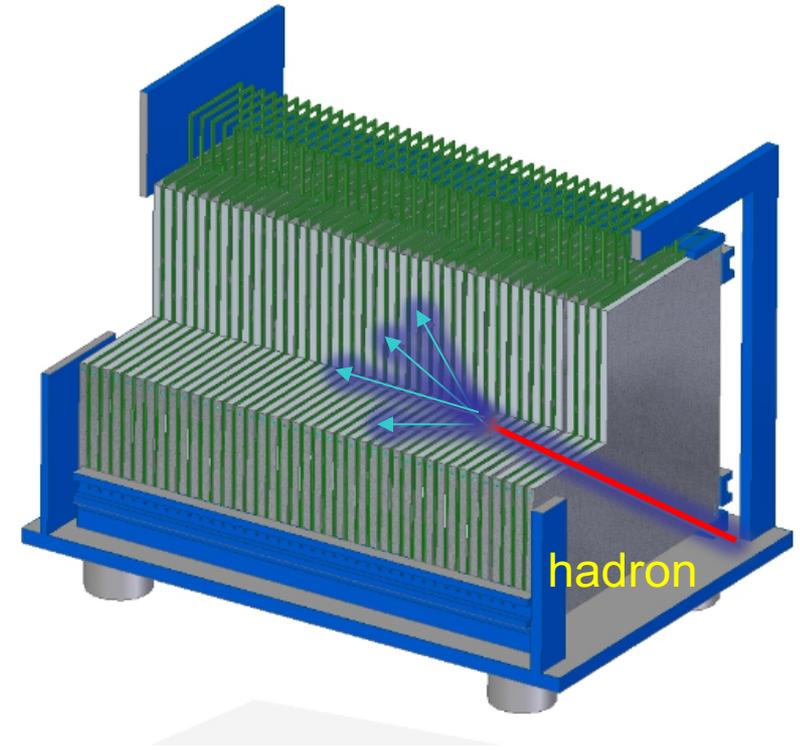
Outline

- CEPC AHCAL Status
 - Scintillators mass production and test
 - SiPM batch test
 - HBU design
 - Cooling simulation and Mechanical Design
- CEPC DHCAL
 - RPC
 - RWELL
- Summary and outlook



AHCAL Prototype

- **Sampling Calorimeter**
 - 40 layers, ~ 5 N.I.L
 - $72\text{ cm} \times 72\text{ cm}$
- **Absorber**
 - Iron, 2 cm thickness
- **Sensitive Detector**
 - Scintillator+SiPM, Number:13,960
 - Cell size: $40\text{ mm} \times 40\text{ mm} \times 3\text{ mm}$
 - SiPM: HPK and NDL
- **Electronics**
 - SPIROC2E ASIC Chip

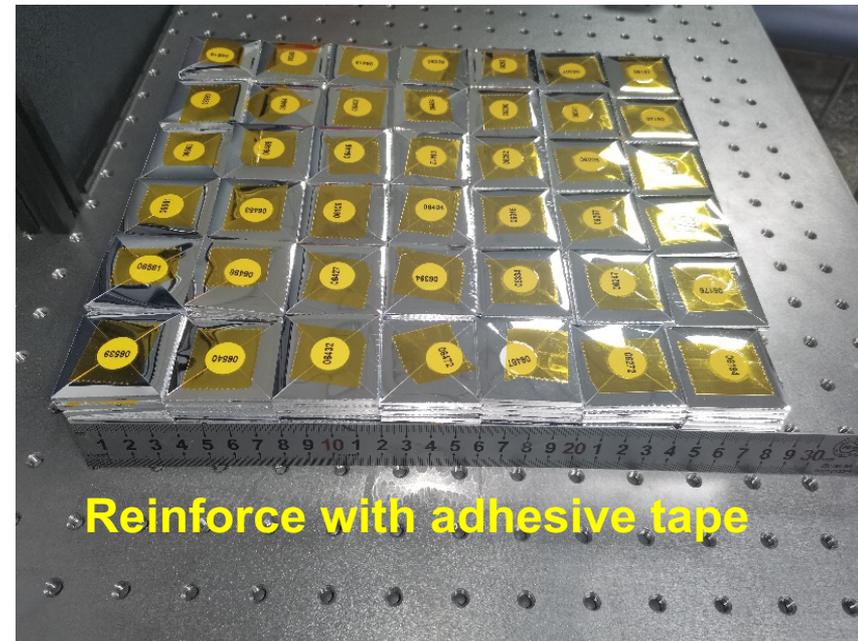
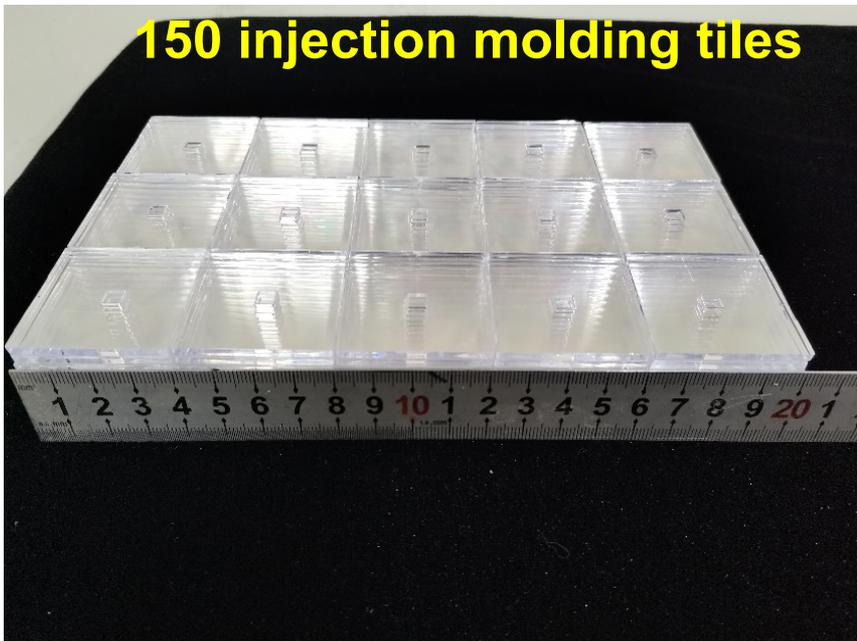


AHCAL Structure



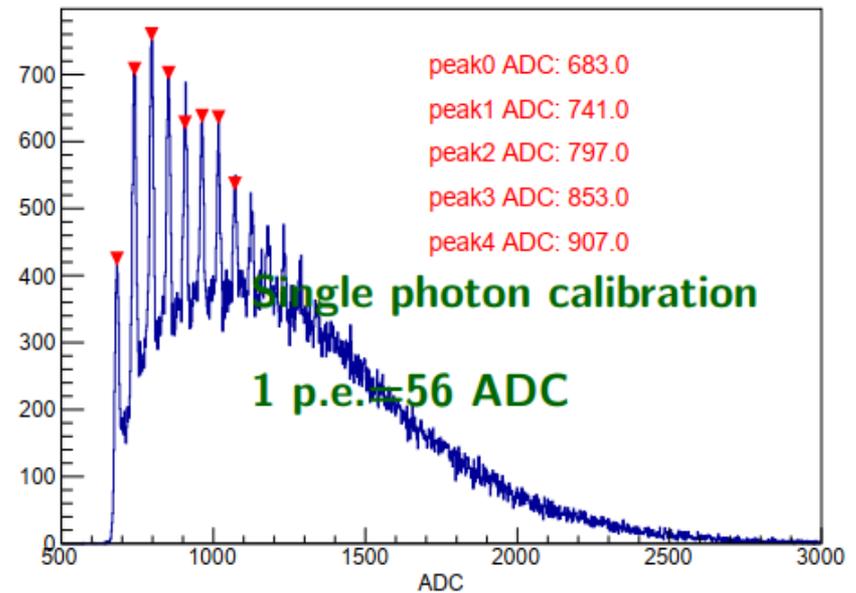
Scintillator mass production and packaging

- ◆ More than **15000** scintillators were produced based on ejection molding and packaging using ESR film in August



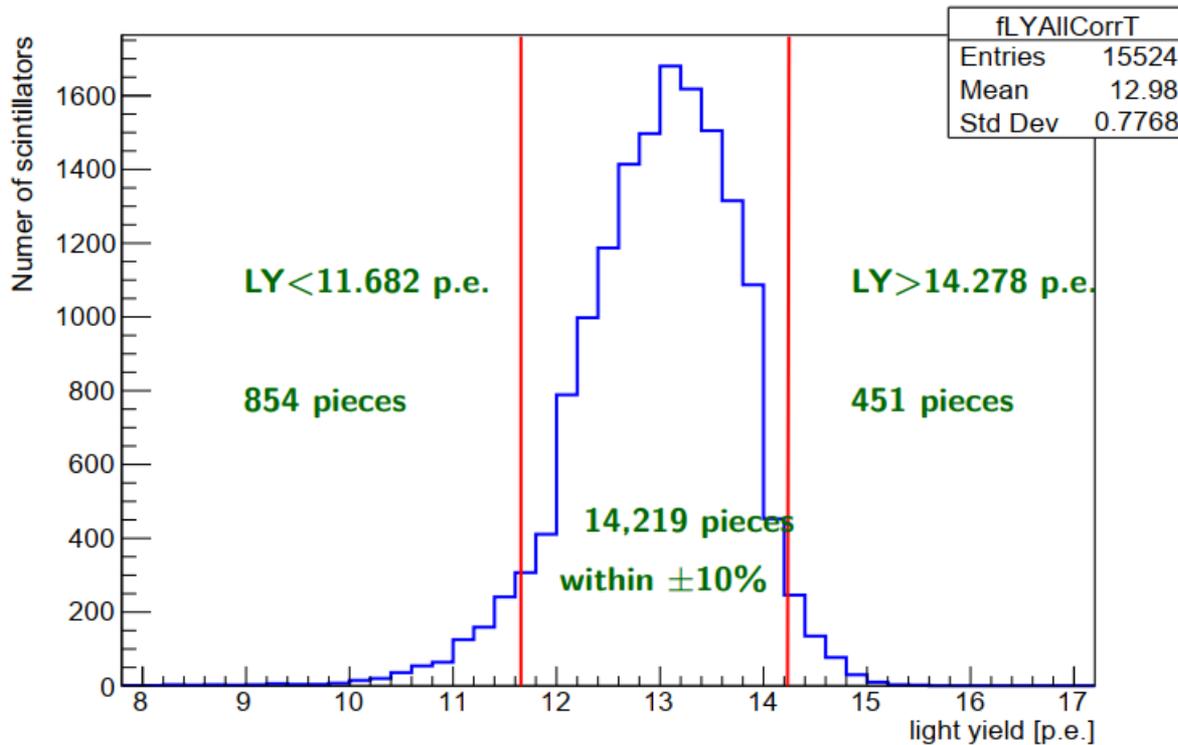
Scintillator batch test

- ◆ All the packaged scintillators (~15000) have been tested using Sr-90 β -ray source
 - ◆ SJTU, USTC
- ◆ The automatic displacement platform controls the movement of radioactive source and tests the scintillator one by one



Scintillator batch test

- ◆ 14,219 pieces within 10% of 15,524 pieces in total. About 91.6% of scintillators are qualified (within 10% of LY window).

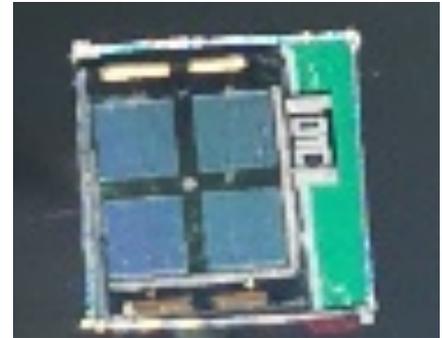


SiPM Procurement and testing

◆ Two different types SiPM were selected in this prototype

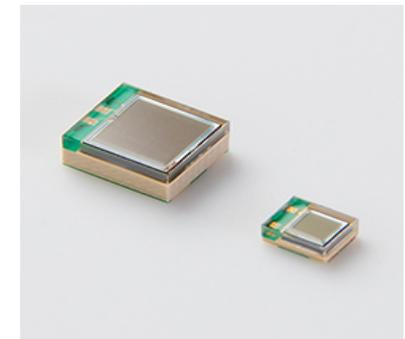
◆ NDL, 1700 pieces

◆ HAMAMATSU, ~13000 pieces



NDL

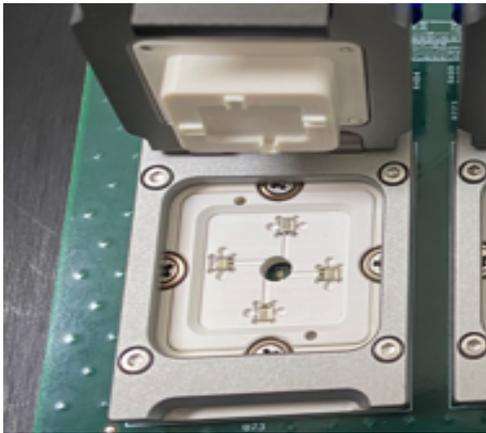
Company	NDL	HPK
Type	22-15	S14160-1315PS
Sensitive area (mm ²)	1.6*4	1.69
PDE (%)	40	32
Gain (*10 ⁵)	2.4	3.6
Pixel No.	7400*4	7284
Breakdown Voltage (V)	28	38
OverVoltage (V)	4	4
Dark Count (kHz)	330*4	120
Cross Talk (%)	8.5	1.0



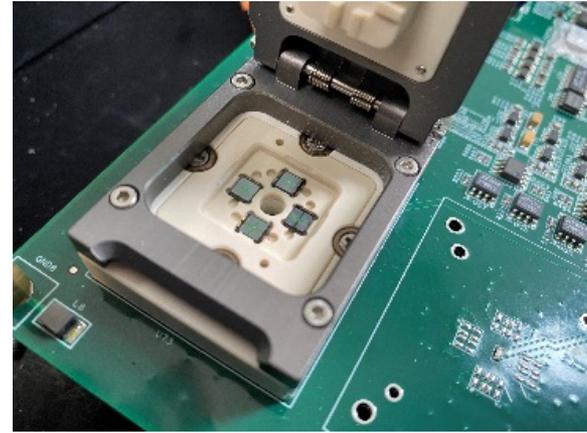
S14160-1315PS

SiPM bench test system

- Two sets of SiPM batch test systems were developed
 - NDL SiPM
 - HPK SiPM



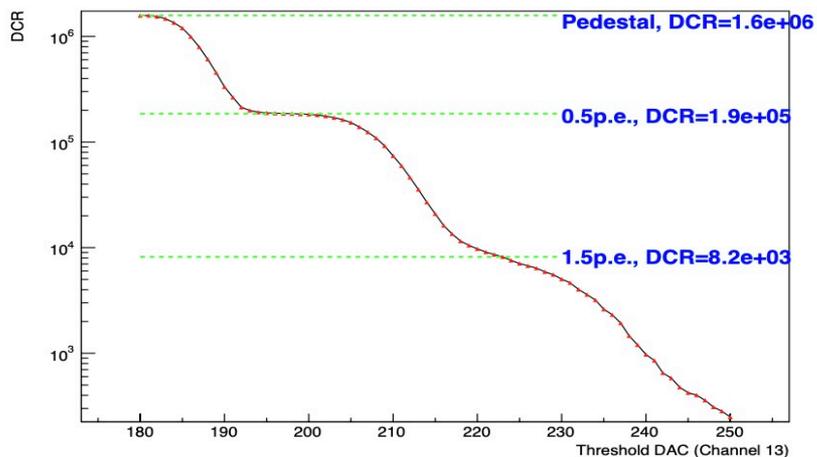
HPK



NDL

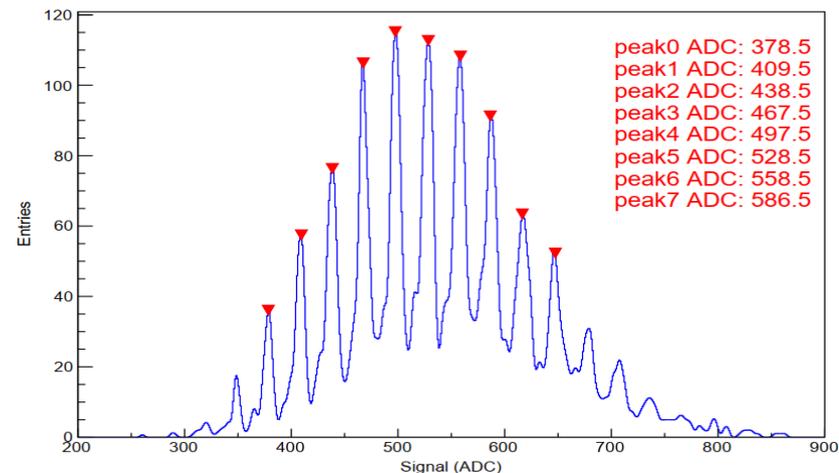


HPK SiPM Test



Dark Counting Rate

chip0 channel11 HV41.4 multi peak



Photon-electron peak

Electrical and optical characteristics (Typ. Ta=25 °C, VR=Vop, unless otherwise noted)

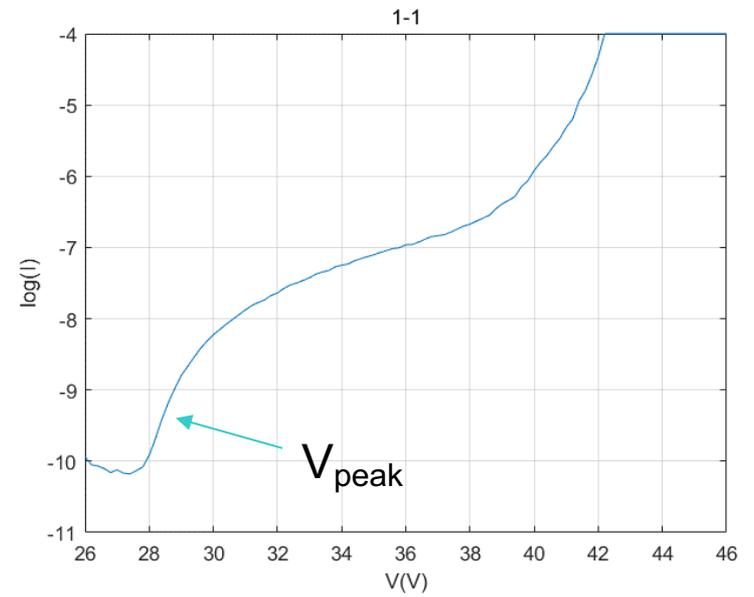
Parameter	Symbol	S14160				Unit
		-1310PS	-3010PS	-1315PS	-3015PS	
Spectral response range	λ	290 to 900				nm
Peak sensitivity wavelength	λ_p	460				nm
Photon detection efficiency at λ_p^{*3}	PDE	18		32		%
Breakdown voltage ^{*4}	VBR	38±3				V
Recommended operating voltage ^{*4}	Vop	VBR + 5		VBR + 4		V
Vop variation within a reel	-	±0.1				V
Dark count rate ^{*5}	typ.	120	700	120	700	kcps
	max.	360	2100	360	2100	
Direct crosstalk probability	Pct	< 1				%
Terminal capacitance at Vop	Ct	100	530	100	530	pF
Gain	M	1.8×10^5		3.6×10^5		-
Temperature coefficient of Vop	$\Delta TVop$	34				mV/°C

*3: Photon detection efficiency does not include crosstalk and afterpulses.

NDL SiPM



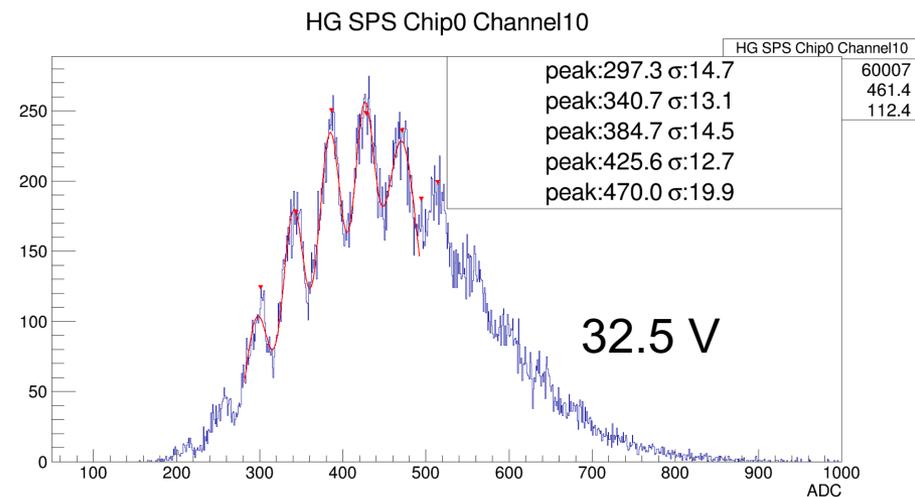
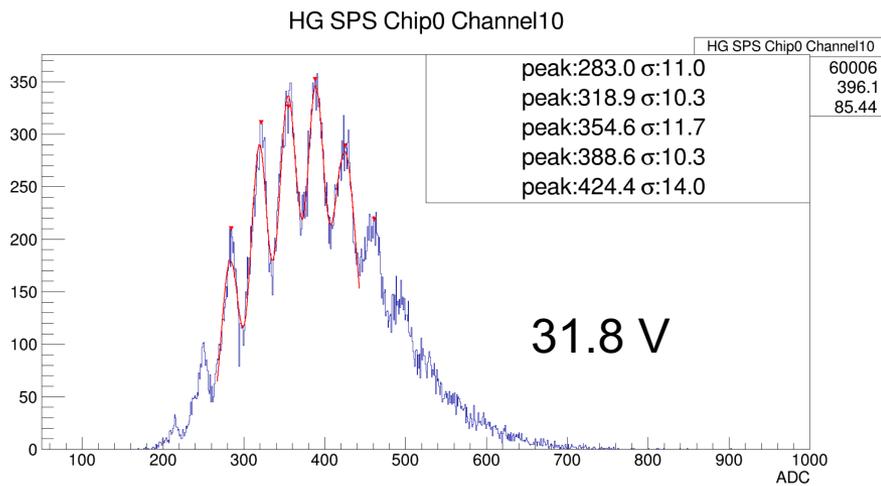
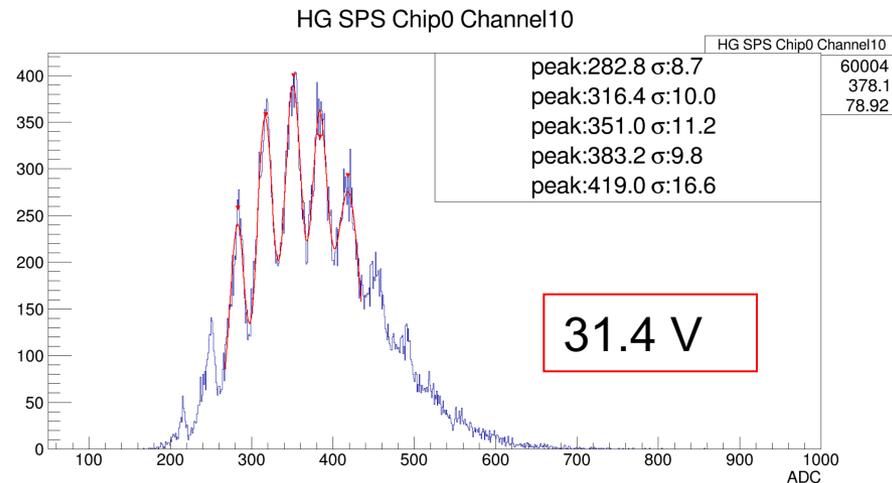
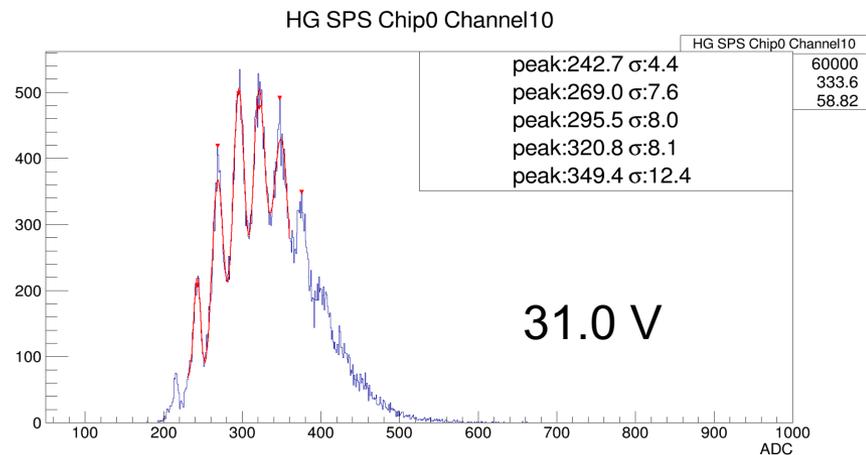
NDL SiPM



I-V curve

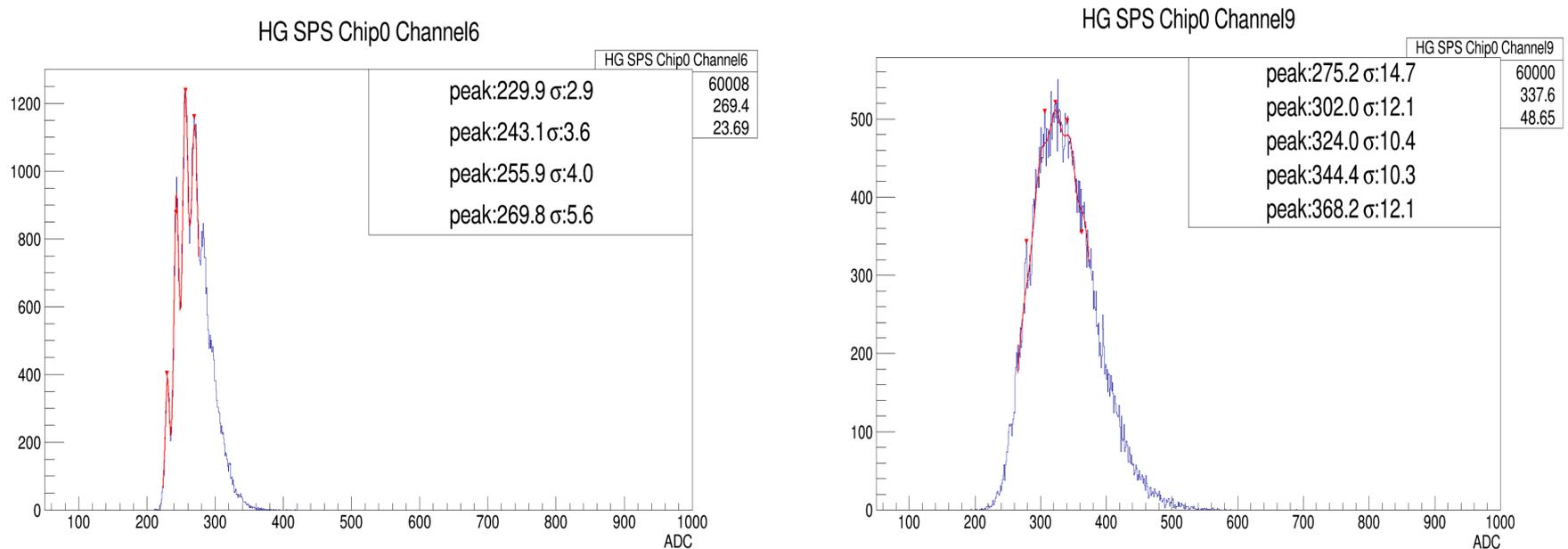


NDL SiPM photon electron spectrum



NDL SiPM photon electron spectrum

- we found that the SNR of a few SiPM was very small
- the photoelectric peaks disappeared with the increase of voltage

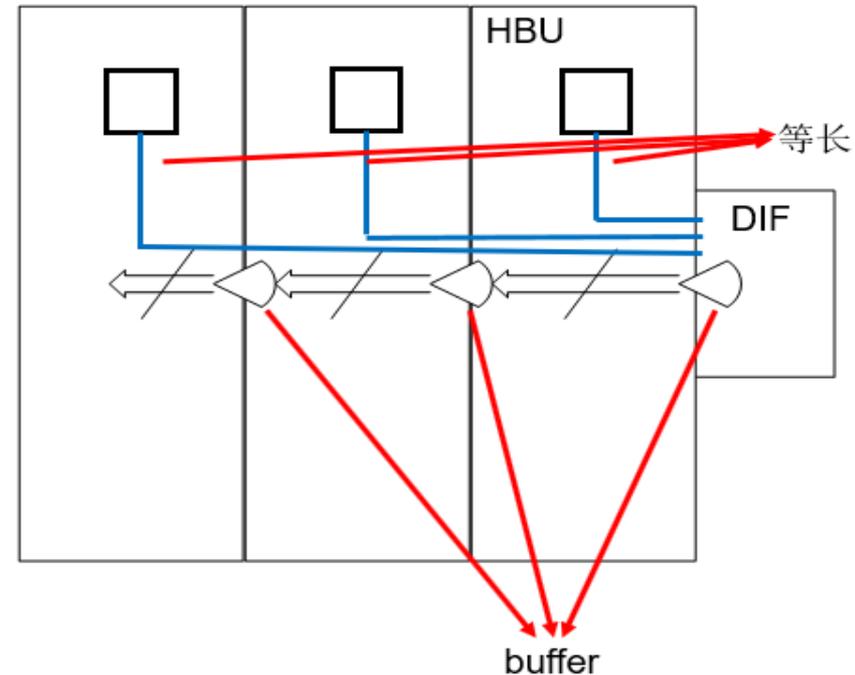


At present, these SiPMs account for 7% of the total



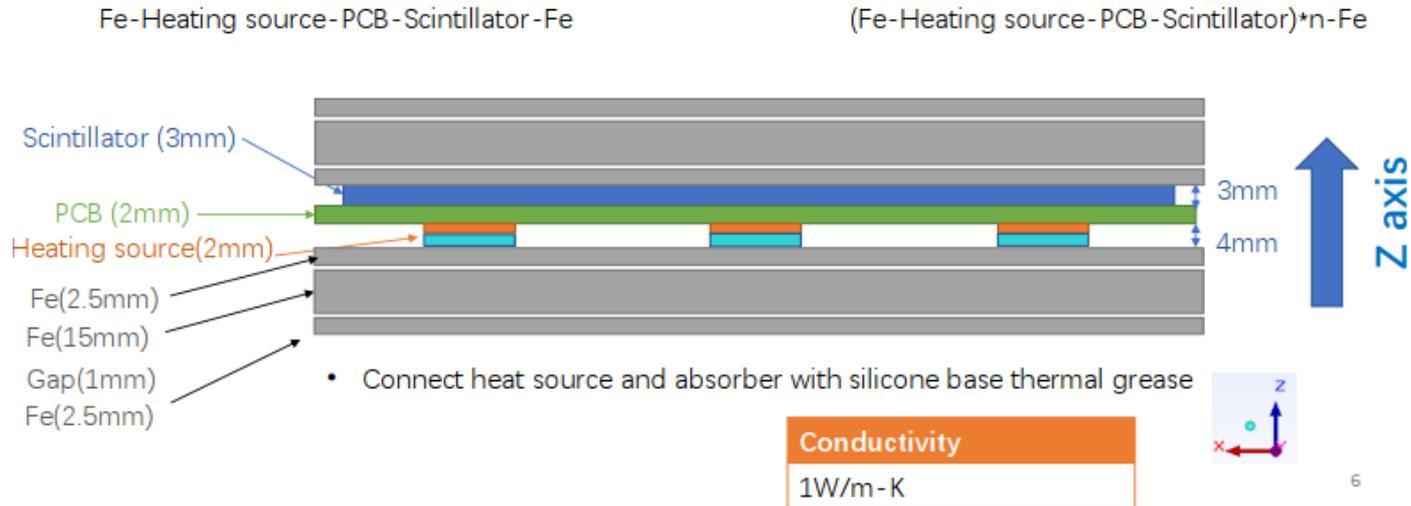
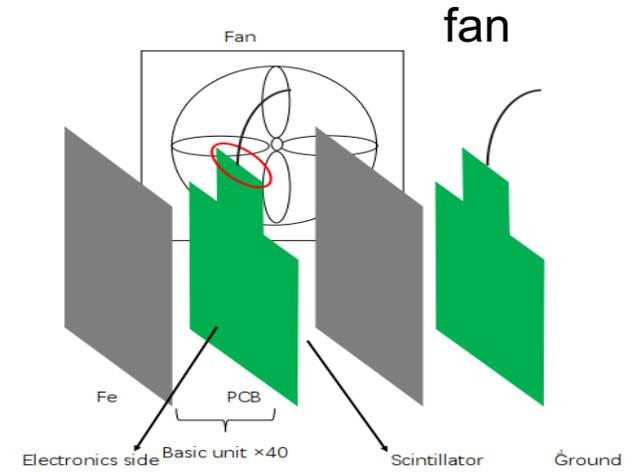
HBU-v2 update

- Optimize HBU size and Type-C interface
- Add additional buffer to the sub-board to ensure the signal integrity
- Keep real-time control signal among SP2e equaling to ensure all the SP2e in a same condition

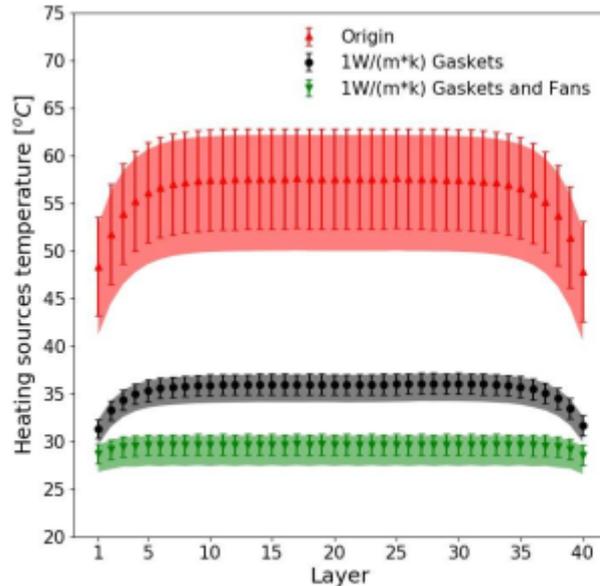


Cooling simulation

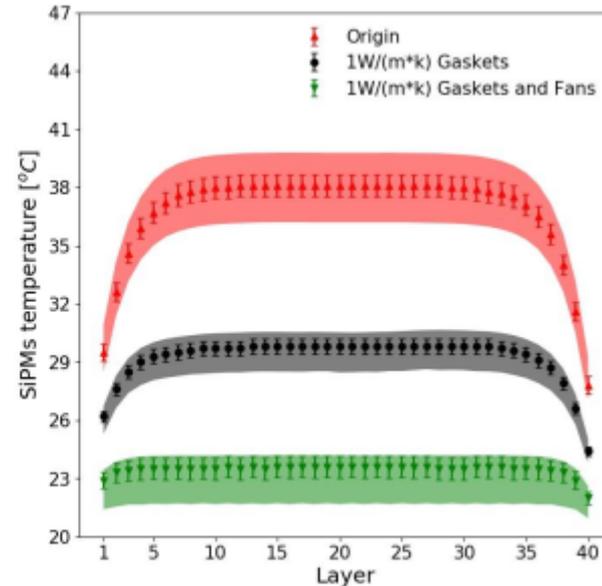
- The power consumption of each layer of HBU is about 4 W
- The main heat sources are electronic chips
- In order to reduce the influence of temperature, we add some fans next to the AHCAL



Cooling simulation



Heating sources



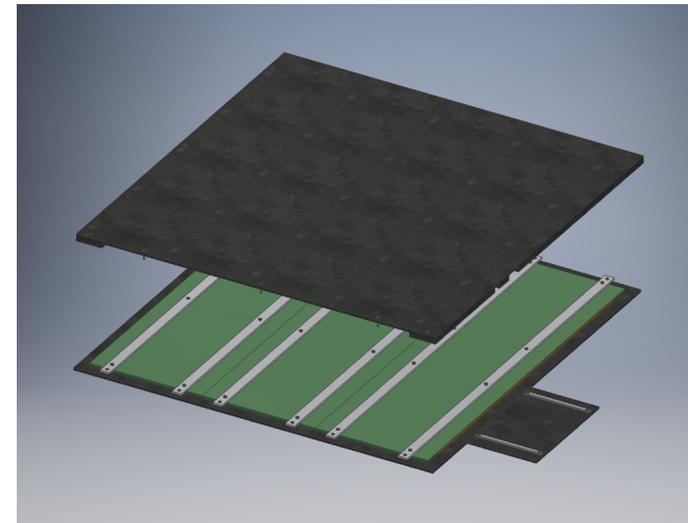
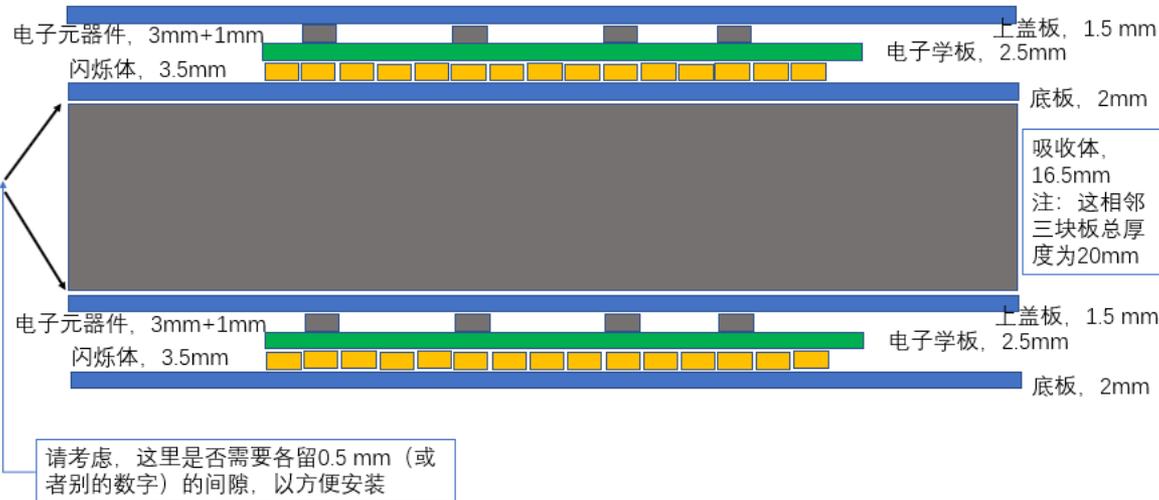
SiPMs

- For heating sources: The mean temperature of the origin: 48°C to 58°C. Thermal conductive rubbers reduce the mean temperature by about 20°C. Fans further reduce the average temperature by about 6°C.
- For SiPMs: The mean temperature of the origin: 28°C to 38°C. Thermal conductive rubbers reduce the mean temperature by about 8°C. Fans further reduce the average temperature by about 6°C.



HBU box mechanical design

- In order to facilitate testing and transportation, each HBU has a cassette
- We choose iron as the material of the box, and the mass of this part is directly deducted from the absorber



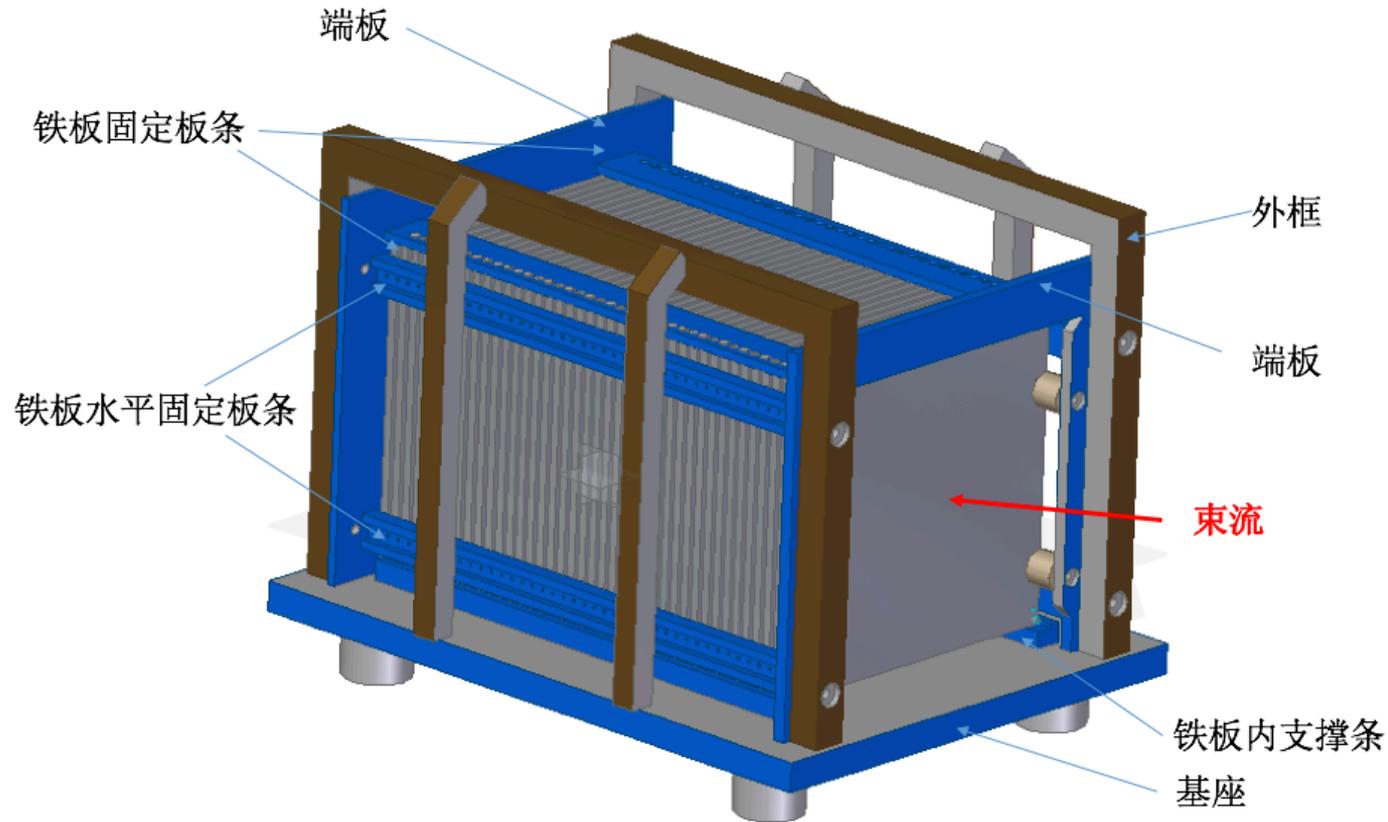
HBU box mechanical design

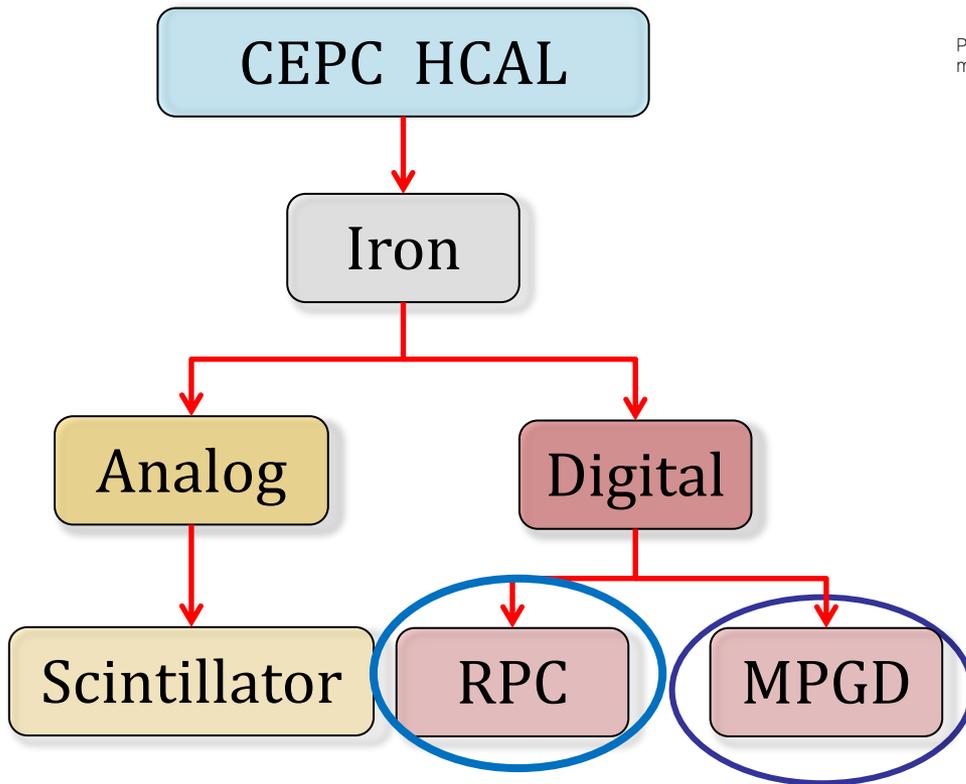
- The first version has been processed and is being trial assembled with HBU
- Heat dissipation test shall be carried out after welding of HBU



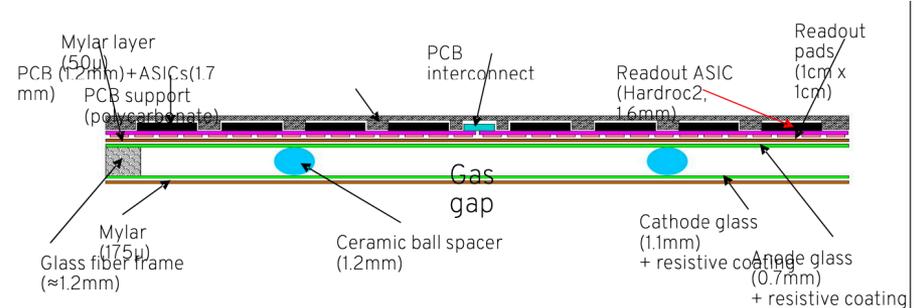
HBU box mechanical design

Then we can install these cassettes directly into the supporting structure of the prototype

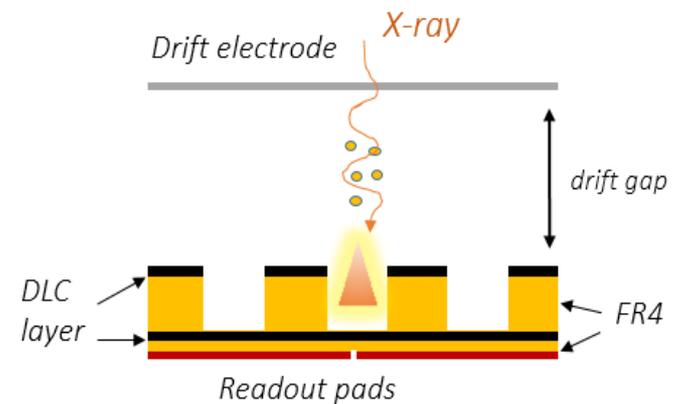




- Resistive Plate Chamber

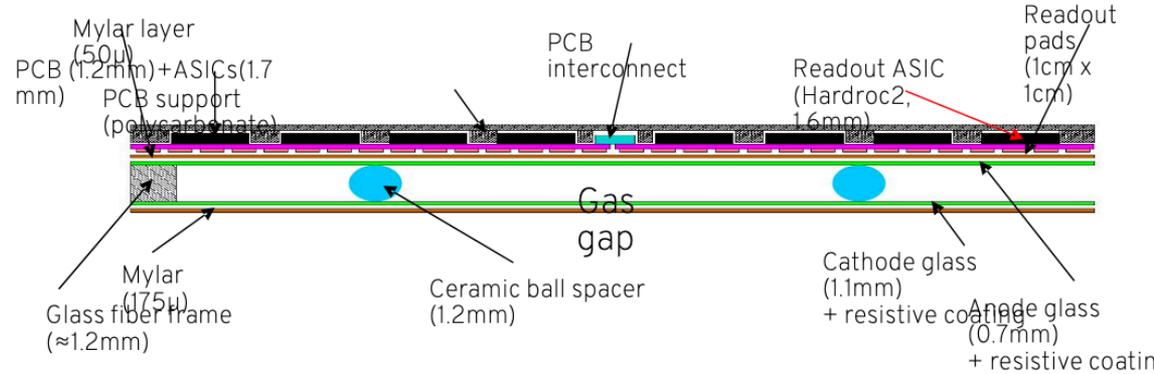
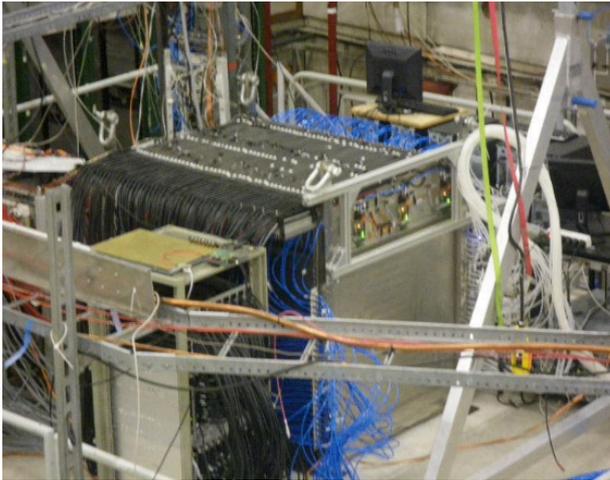


- Resistive WELL detector (RWELL):



DHCAL Based on GRPC

Size : 1m*1m*1.3m
 Nbr layers : 48 of RPC
 Cell Size : 1cm*1cm



ASIC HARDROC (64 ch)
 3-threshold: 110fC, 5pC, 15pC

(0.12λ_I, 1.14X₀)

Stainless steel Absorber(15mm)

Stainless steel wall(2.5mm)

GRPC(6mm ≈ 0 λ_I, X₀)

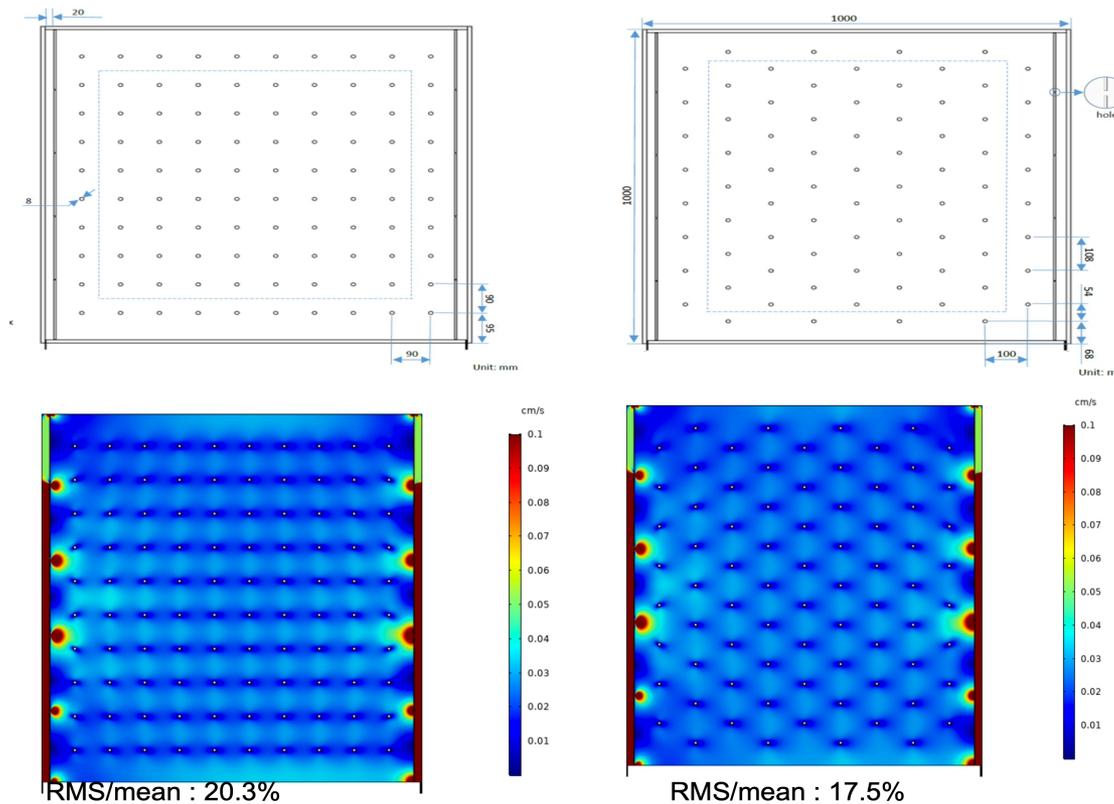
Stainless steel wall(2.5mm)

3 mm RPC (glass)
 1.2 - 1.4 mm PCB
 1.6 mm ASIC



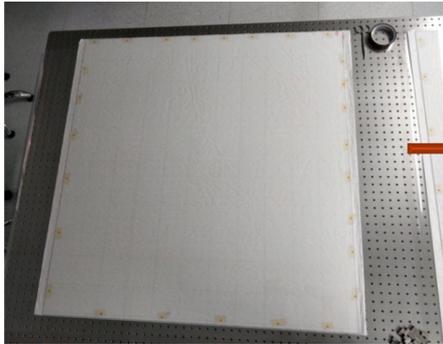
Gas flow simulation for GRPC

- Gas flow has a strong impact on the uniformity, efficiency of GRPC
 - The bigger chamber, the more critical it's become
 - For large GRPC 1820 × 990 mm, simulate the gas flow impact
 - Compare the spacer position, the velocity is more uniform with the shifted design

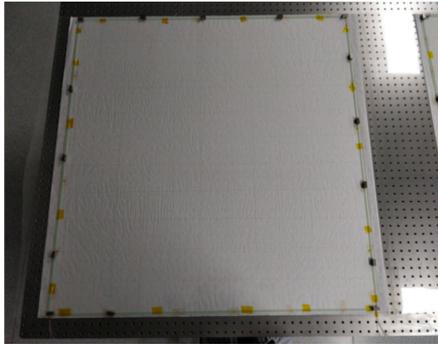


GRPC construction

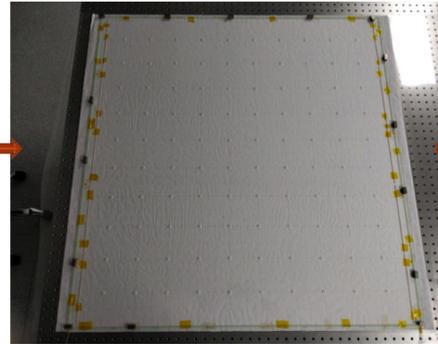
Cleaning



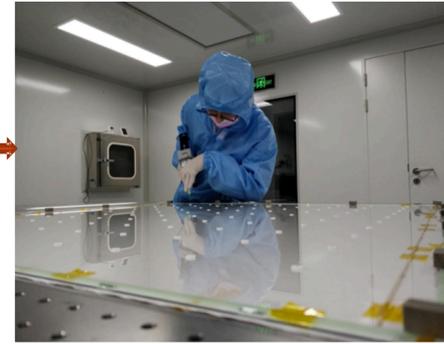
Walls positioning



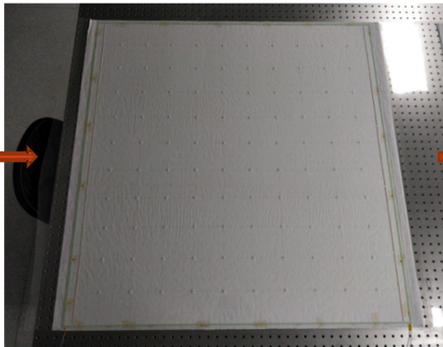
Spacers positioning



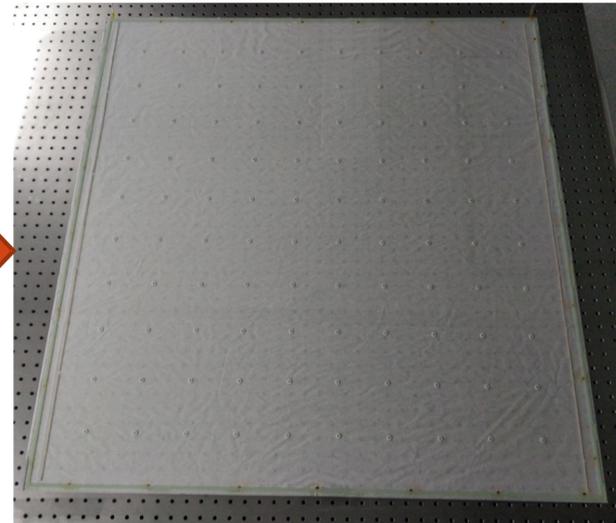
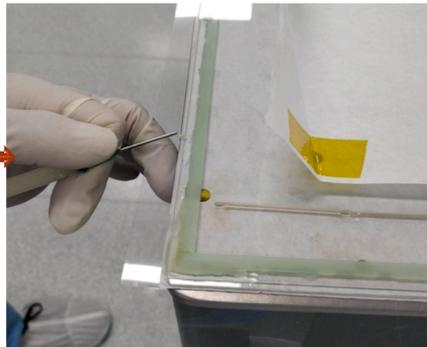
Walls/spacers gluing



Flipping and 2nd glass positioning

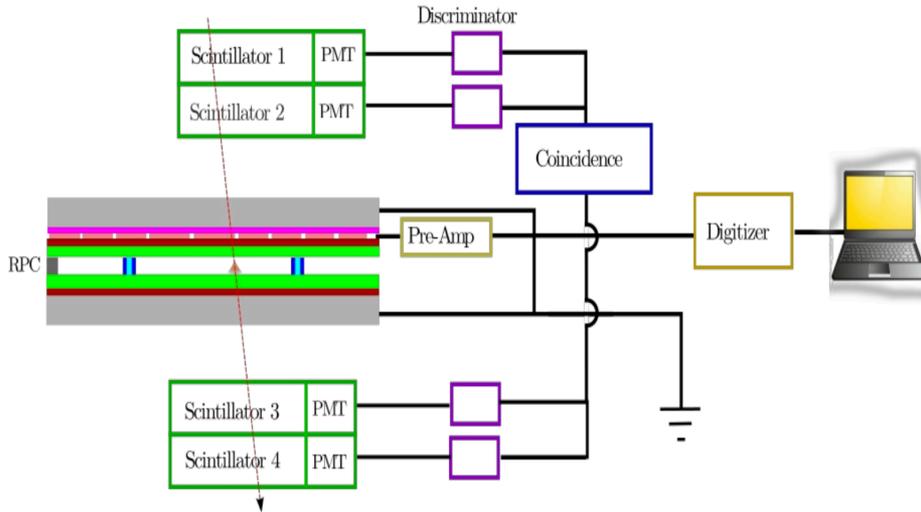


2nd glass gluing
gas tightening

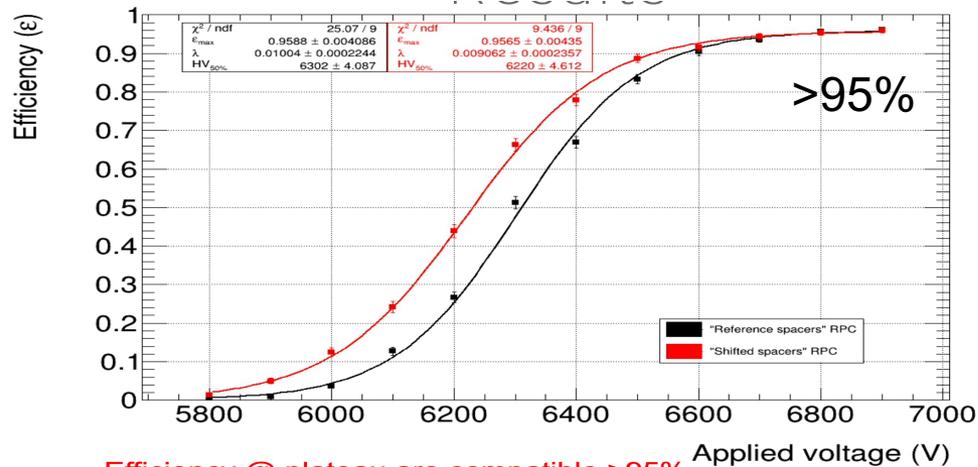


GRPC test

Cosmic ray test



efficiency



Fabrication of RWELL detector

100cm × 50cm RWELL:



Painting the glue



Pumping and drying

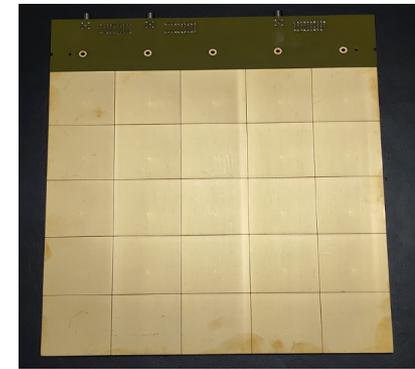


Assembling



100cm × 50cm RWELL detector

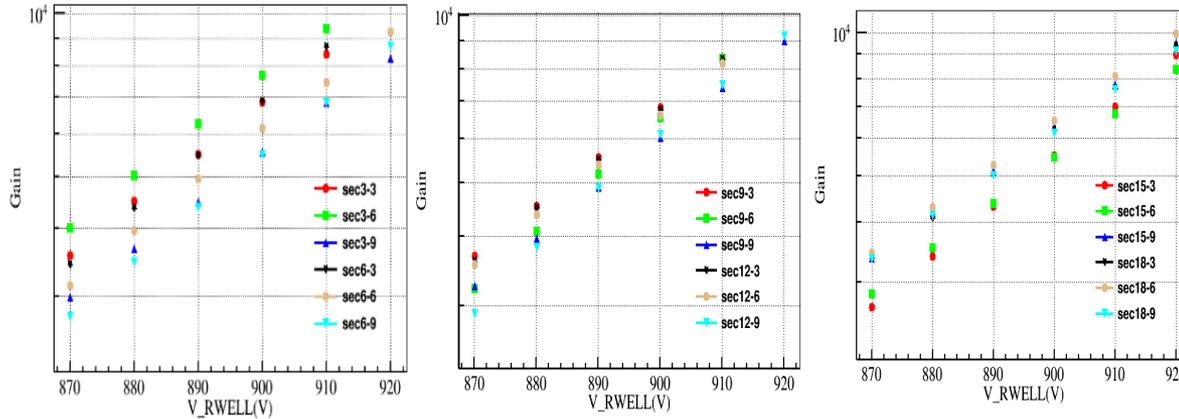
- We make a special PCB and use it as the gluing mask;
- We put glue on both resistive layer PCB and THGEM PCB;
- A vacuum platform was used for gluing;
- 8 pieces of readout PCB are used, there are 25 pad (Pad size 5cm × 5cm) on each pcb



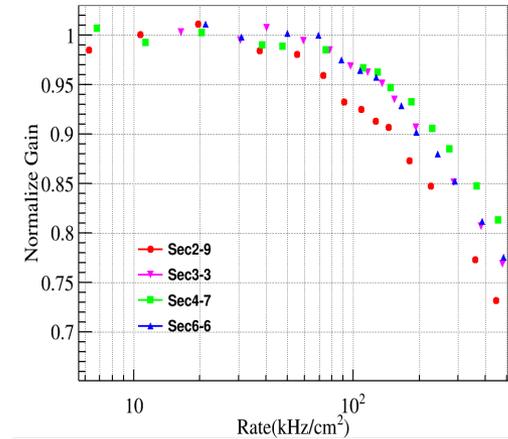
25 cm × 25 cm Readout PCB

RWELL performance

- Gain vs HV:

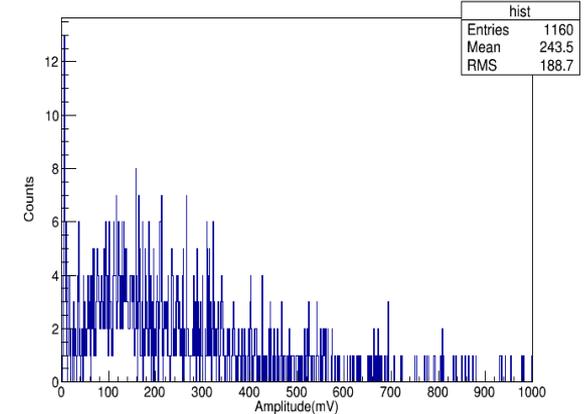
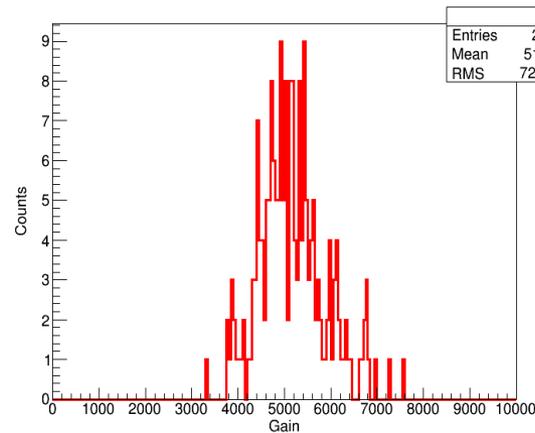
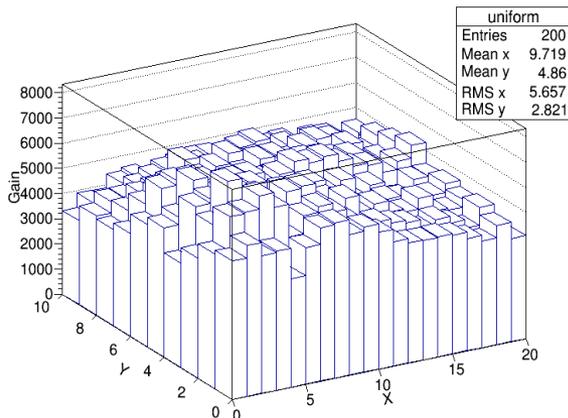


- Rate capability: **>100 kHz/cm²**



- Gain Uniformity : **RMS/Mean ~14.0% @ ~5175 Gain**

- Efficiency : **~95.9%**



Summary and outlook

- The light yield test of all scintillators has been completed.
 - A total of 14219 / 15524 scintillators meet our requirement (the prototype needs 13960)
- Two SiPM test systems are developed and applied to the test
 - One is for SiPM of HAMAMATSU, the other is for NDL
- The new HBU has been tested
- Under the existing power consumption, the influence of air cooling design of AHCAL was simulated
 - The design of fan + thermal conductive rubber pad can effectively reduce the temperature of the AHCAL
- HBU cassette handling is being carried out
- The DHCAL based on GRPC and RWELL are carried out in an orderly manner



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THANKS



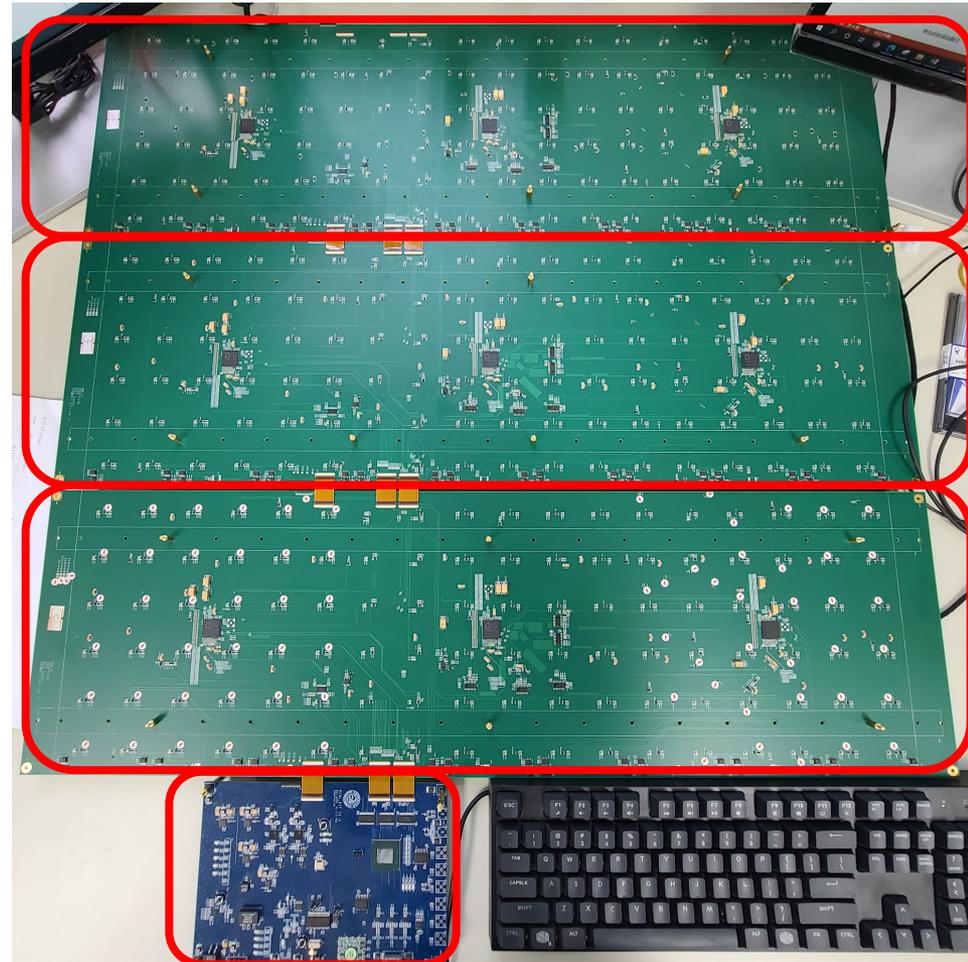
backup



HCAL Baseboard Unit Status

HBU

- One layer has 3 sub-HBUs
- One sub-HBU is $78.5 \times 24\text{cm}^2$
- Flexible boards are used to transmit power and signal between the 3 sub-HBUs and DIF
- Each sub-HBU has 3 SPIROC2E chips
 - The chips were packaged in China



Data InterFace
(DIF) board



ECAL

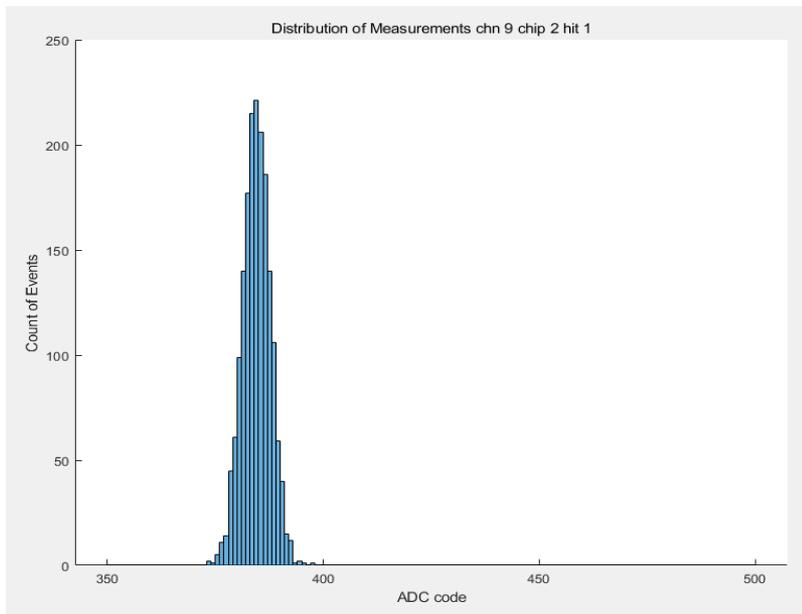
AHCAL

2021/10/27

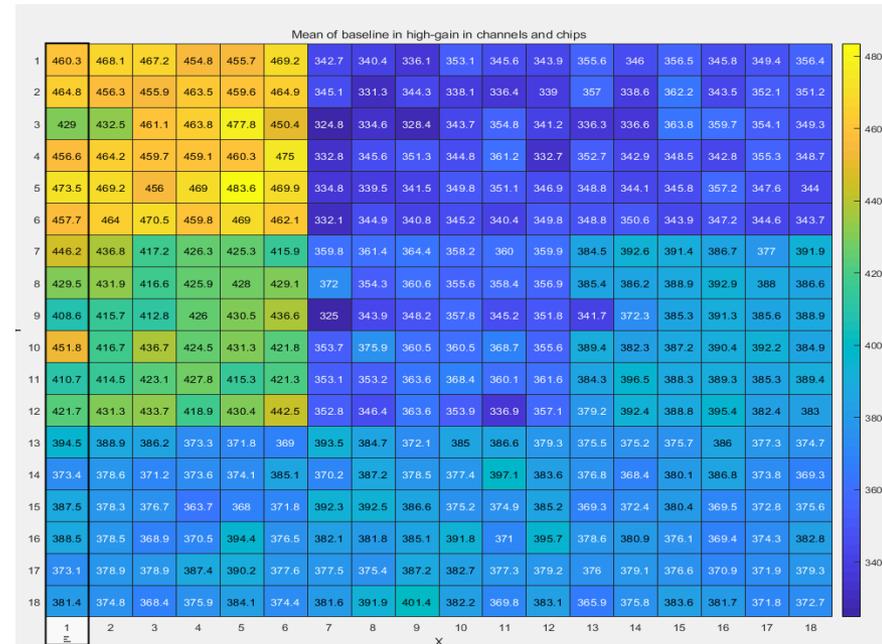
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Pedestal of HBU

- The pedestal of each channel was calibrated using random trigger
- The pedestal positions are differences between chips
- The channels of the same chip are relatively uniform
- The pedestal width has little to do with the chip



The pedestal of one channel



The pedestal of each channel in HBU



HBU Support Frame

- A 5mm thick Al support frame is machined for trial assembly and testing with HBU
- The optimization of the support frame will be discussed next step

